
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(213.003-D1)

In re Application of: **YE ET AL.**

Serial No: **10/756,718**

Filed: **JANUARY 13, 2004**

Title: **METHOD AND APPARATUS FOR MONITORING
INTEGRATED CIRCUIT FABRICATION**

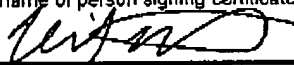
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) Group Art Unit: **2857**

) Examiner: **E. RAYMOND**

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AMENDMENT AFTER ALLOWANCE

Dear Sir:

Pursuant to 37 CFR 1.312, Applicants respectfully request entry of the following amendment: